Fabrication of fully epitaxial Co$_2$MnSi/MgO/Co$_2$MnSi magnetic tunnel junctions

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Fully epitaxial magnetic tunnel junctions (MTJs) were fabricated with full-Heusler alloy Co$_2$MnSi thin films as both lower and upper electrodes and with a MgO tunnel barrier. The fabricated MTJs showed clear exchange-biased tunnel magnetoresistance (TMR) characteristics with high TMR ratios of 179% at room temperature (RT) and 683% at 4.2 K. In addition, the TMR ratio exhibited oscillations as a function of the MgO tunnel barrier thickness ($t_{\text{MgO}}$) at RT, having a period of 0.28 nm, for $t_{\text{MgO}}$ ranging from 1.8 to 3.0 nm. © 2008 American Institute of Physics.

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Highly spin-polarized electrons are essential for spintronic devices, in which both the charge and the spin of the electron are utilized as the information carrier. Half-metallic ferromagnets (HMFs) are characterized by a complete spin polarization at the Fermi level ($E_F$) due to the existence of an energy gap for one spin direction (usually minority spin) (Ref. 1). The potentially high spin polarization of HMFs is widely advantageous for ferromagnetic electrodes used in spintronic devices in terms of achieving high tunnel magnetoresistance (TMR) ratios in magnetic tunnel junctions (MTJs) and efficient spin injection from ferromagnetic electrodes into semiconductors.

Co-based full-Heusler alloys (Co$_2$YZ) (Ref. 2) have attracted much interest as a preferable ferromagnetic electrode material for spintronic devices. This is because of the HMF nature theoretically predicted for many of these alloys, and because of their high Curie temperatures, which are well above room temperature (RT). In particular, Co$_2$MnSi (CMS) has especially attracted interest because of its half-metallic nature theoretically predicted, with a large energy gap of 0.42 eV (Ref. 3) to 0.81 eV (Ref. 4). Much effort has been dedicated to fabricating and characterizing CMS thin films$^{5-7}$ and also to fabricating MTJs with a CMS as a lower electrode or CMS as both lower and upper electrodes with an amorphous AlO$_x$ barrier.$^{8-10}$

We recently developed fully epitaxial MTJs with a Co$_2$YZ thin film [Co$_{0.95}$Fe$_{0.05}$Al (CCFA), Co$_2$MnSi (CMS), or Co$_2$MnGe (CMG)] as a lower electrode, and a MgO (001) tunnel barrier.$^{11-16}$ The relatively small lattice mismatch between Co$_2$YZ and MgO for a 45° in-plane rotation (e.g., about −3.7% for CCFA and −5.1% for CMS) enabled us to successfully fabricate fully epitaxial MTJ trilayers featuring highly smooth and abrupt interfaces.$^{12-15}$ We have demonstrated relatively high TMR ratios of 109% at RT (317% at 4.2 K) for CCFA/MgO/Co$_2$MnSi$_{50}$ MTJs,$^{14}$ 90% at RT (192% at 4.2 K) for CMS/MgO/Co$_{50}$Fe$_{50}$ MTJs,$^{13}$ and 83% at RT (185% at 4.2 K) for CMG/MgO/Co$_{50}$Fe$_{50}$ MTJs.$^{16}$ However, there is much room for further enhancement of the TMR ratio of these fully epitaxial MTJs. Since Co$_2$YZ thin films potentially have a high spin polarization value at RT, a promising approach would be to use these films as both the lower and upper electrodes.$^{10,17,18}$

In the present study, as an extension of our work on CMS/MgO/Co$_{50}$Fe$_{50}$ MTJs,$^{13}$ we fabricated fully epitaxial MTJs with CMS electrodes as both the lower and upper electrodes and with a MgO tunnel barrier and investigated their TMR characteristics.

We fabricated exchange-biased MTJs. In order to obtain exchange biasing, a CMS upper electrode was used in the antiferromagnetically coupled CMS/Ru/Co$_{90}$Fe$_{10}$ trilayer exchange-biased through the Co$_{90}$Fe$_{10}$/IrMn interface.$^{19}$ The MTJ layer structure was grown on a MgO (001) single-crystal substrate and, from the substrate side, was as follows: MgO buffer (10 nm)/CMS (50 nm)/MgO barrier (0.8–3.4 nm)/CMS (5 nm)/Ru (0.8 nm)/Co$_{90}$Fe$_{10}$ (2 nm)/IrMn (10 nm)/Ru cap (5 nm). Each layer in the MTJ layer structure was successively deposited in an ultrahigh vacuum chamber (base pressure of ~$6 \times 10^{-8}$ Pa) using magnetron sputtering and electron beam (EB) evaporation. The CMS lower electrode was deposited by magnetron sputtering at RT and subsequently annealed in situ at 600 °C, for which we have already confirmed the $L_2^1$ structure formation from x-ray pole figure measurements.$^7$ The upper CMS electrode was also deposited at RT and subsequently annealed in situ at up to 600 °C. An appropriate temperature for in situ annealing just after the deposition of an upper CMS electrode ($T_a$) is critically important for fabricating high-performance MTJs with a CMS film as the upper electrode, i.e., a higher $T_a$ would be favorable for obtaining a high spin polarization of the upper CMS film through the improvement of structural properties,$^7$ and a $T_a$ that does not cause the diffusion problem is also required. Given these guidelines, we fabricated CMS/MgO/CMS MTJs (hereafter, CMS-MTJs) with $T_a$ ranging from 400 to 600 °C.
junction sizes were 8 nm. We used spectrometry. We measured the pressure during deposition of the MgO tunnel barrier was 10−7 Pa. The nominal thickness of the MgO tunnel barrier was varied from 0.8 to 3.4 nm on each 20×20 mm² substrate. The composition of the fabricated CMS film was determined to be Co2.0Mn0.91Si0.93 by inductively coupled plasma optical emission spectroscopy. We fabricated MTJs with the layer structure described above using photolithography and Ar ion milling. The fabricated junction sizes were 8×8 and 10×10 μm². We measured the TMR characteristics of the fabricated MTJs using a dc four-probe method.

Figure 1 shows RHEED patterns, along the azimuths of [100]MgO and [110]MgO (corresponding to [110]CMS and [100]CMS, respectively), observed in situ for each successive layer in the Co₂MnSi (CMS)/MgO/CMS trilayer structure during fabrication. (a) A lower CMS electrode deposited at RT and annealed in situ at 600 °C. (b) A MgO tunnel barrier, and (c) an upper CMS electrode deposited at RT and annealed at 500 °C. The lower and upper CMS electrodes both show additional streak patterns (indicated by arrows), showing that both had the L₂₁ structure.

The MgO tunnel barrier layer was deposited by EB evaporation at RT. The deposition rate was 0.01 nm/s and the pressure during deposition of the MgO tunnel barrier was around 6×10⁻⁷ Pa. The nominal thickness of the MgO tunnel barrier (tMgO) was varied from 0.8 to 3.4 nm on each 20×20 mm² substrate. The composition of the fabricated CMS film was determined to be Co₂.0Mn0.91Si0.93 by inductively coupled plasma optical emission spectroscopy. We fabricated MTJs with the layer structure described above using photolithography and Ar ion milling. The fabricated junction sizes were 8×8 and 10×10 μm². We measured the TMR characteristics of the fabricated MTJs using a dc four-probe method.

Figure 1 shows RHEED patterns, along the azimuths of [100]MgO and [110]MgO (corresponding to [110]CMS and [100]CMS, respectively), observed in situ for each successive layer in the CMS/MgO/CMS trilayer structure during fabrication. Sharp streak patterns dependent on the electron injection direction were obtained for each successive layer in the trilayer structure, clearly indicating all the layers, including the CMS lower electrode, MgO tunnel barrier, and CMS upper electrode, grew epitaxially. We also observed 1/2-order superlattice reflections along the [110]CMS direction in the RHEED patterns for both the CMS lower electrode annealed at 600 °C and the CMS upper electrode annealed at 400–600 °C [Fig. 1(c)], indicating that both had the L₂₁ structure.

Now, we will describe the TMR characteristics of the fully epitaxial CMS-MTJs. Figure 2(a) shows the TMR ratio at RT as a function of Tₐ. The bars for TMR ratios for Tₐ of 550 and 600 °C indicate the scattering of the typical TMR ratio for each MTJ fabrication run within several runs. The TMR ratio at RT increased significantly with increasing Tₐ from 80% for Tₐ of 400 °C to 165±17% for Tₐ of 550 °C, and it saturated for Tₐ ranging from 550 to 600 °C. The marked increase of the TMR ratio with increasing Tₐ suggests that in situ annealing at around 550 to 600 °C considerably increased the tunneling spin polarization of the upper CMS electrode through the improvement of structural properties.

Figure 2(b) shows typical TMR curves at RT and 4.2 K for a fully epitaxial CMS/MgO (2.1 nm)/CMS MTJ with Tₐ of 600 °C. The junction size was 10×10 μm². The bias voltage was 1 mV. Clear exchange-biased TMR characteristics were obtained. The MTJ demonstrated high TMR ratios of 179% at RT and 683% at 4.2 K. These values are significantly higher than the 90% at RT and 192% at 4.2 K previously obtained for fully epitaxial CMS/MgO/CoₙFeₙ MTJs. The significantly enhanced TMR ratios at both RT and 4.2 K show that fully epitaxial MTJs with CMS thin films as both the lower and upper electrodes and with a MgO tunnel barrier are advantageous for obtaining high TMR ratios.

Figure 3(a) shows typical tMgO dependence of Rₚ and RₐP at RT for MTJs with Tₐ of 550 °C fabricated on a 20×20 mm² MgO(001) substrate, where Rₚ and RₐP are the respective tunnel resistances for the parallel and antiparallel magnetization configurations between the upper and lower electrodes. The nominal junction size was 10×10 μm². The bias voltage was 5 mV. Both Rₚ and RₐP showed clear exponential dependence on tMgO for a relatively wide tMgO range from 1.7 to 3.0 nm, indicating typical tunnel junction behavior.

Figure 3(b) shows TMR ratios as a function of tMgO calculated with values of Rₚ and RₐP shown in Fig. 3(a), where the TMR ratio is defined as (RₐP−Rₚ)/Rₚ. The MTJs exhibited relatively high TMR ratios of over 110% at RT for a wide tMgO range from 1.8 to 3.0 nm, and the TMR ratio gradually increased from 112% to 147% for this tMgO range. The TMR ratio versus tMgO shown in Fig. 3(b) suggests oscillations of the TMR ratio as a function of tMgO for tMgO ranging from 1.8 to 3.0 nm. In Fig. 3(b), a fitting line for the TMR ratio versus tMgO with a single period of 0.28 nm is plotted as a guide, and the tMgO dependence of the TMR ratio is relatively well represented by this fitting curve. The oscillation period of 0.28 nm is close to the oscillation period of 0.32 nm for the oscillatory tMgO dependence of Rₚ and RₐP.
observed for fully epitaxial Fe/MgO/Fe MTJs.20,21 We could not extract the oscillatory components of $R_P$ and $R_{AP}$ for the fabricated CMS-MTJs. To observe possible oscillations of $R_P$ and $R_{AP}$ as a function of $t_{MGO}$, the degree of the junction area scattering should be lower than the amplitudes of the oscillatory components of $R_P$ and $R_{AP}$. But this condition was probably not satisfied in the fabricated MTJs. (The MTJ junction size was defined with photolithography.) On the other hand, the junction area scattering does not affect the TMR ratio because that the TMR ratio calculated as $(R_{AP}−R_P)/R_P$ is a quantity independent of the junction area. Thus, the observation of oscillations of the TMR ratio as a function of $t_{MGO}$ is easier than that of oscillations of $R_P$ and $R_{AP}$. To clarify the mechanisms of the observed oscillatory dependence of the TMR ratio, further systematic study for fully epitaxial MTJs with Heusler alloy electrodes and a MgO barrier is needed.

Finally, we will discuss possible reasons for the enhancement of the TMR ratios of the presented MTJs with CMS electrodes and with a single-crystalline MgO barrier compared with previously reported MTJs with a CMS electrode or CMS electrodes and with an amorphous AlOₓ barrier.8–10 First, our approach of growing fully epitaxial MTJ layer structures enables the growth of single-crystalline lower and upper Co₂YZ electrodes. Then, the high-quality single-crystalline Co₂YZ electrodes would lead to a high spin polarization of each ferromagnetic electrode. Second, fully epitaxial MTJ layer structures are advantageous for forming atomically flat and abrupt interfaces in MTJ trilayers. As a result, the high spin polarization of potentially half-metallic CMS thin films is retained at the interfaces. Third, the combination of single-crystalline Co₂YZ thin films as lower and upper electrodes with a single-crystalline MgO tunnel barrier enables the enhancement of the tunneling spin polarization due to preferential tunneling of electrons with $Δ↑$, symmetry.22–24 Fourth, depositing MgO barriers by EB evaporation in a ultrahigh vacuum chamber ensures that the interfacial region of CMS lower electrodes with a MgO barrier is not oxidized, which has been demonstrated directly by x-ray absorption spectroscopy and x-ray magnetic circular dichroism.25

In summary, we fabricated fully epitaxial MTJs with full-Heusler alloy CMS thin films as both lower and upper electrodes and with a MgO tunnel barrier. The fabricated MTJs demonstrated high TMR ratios of 179% at RT and 683% at 4.2 K. The demonstrated high TMR ratios confirm the promise of a single-crystalline CMS film with a combination of a single-crystalline MgO tunnel barrier as ferromagnetic electrodes in spintronic devices.